

INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Not for submission under 37 CFR 1.99)</i>	Application Number		10779373
	Filing Date		2004-02-17
	First Named Inventor		SCHAEPKENS, et al.
	Art Unit		1794
	Examiner Name		Kevin R. Kruer
	Attorney Docket Number		GER01 006

U.S.PATENTS						
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	2	6642652	B2	2003-11-04	Collins, III et al.	
	3	6576351	B2	2003-06-10	Silvernail	
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9	6023371	A	2000-02-08	Onitsuka et al.	
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	1	0026973	WO	A1	2000-05-11	Delta V Technologies, Inc.		<input type="checkbox"/>
	2	0181649	WO	A1	2001-11-01	Battelle Memorial Institute		<input type="checkbox"/>
	3	0182366	WO	A2	2001-11-01	Battelle Memorial Institute		<input type="checkbox"/>
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	1	H. SUZUKI et al., Near-Ultraviolet Electroluminescence from Polysilanes, 331, Thin Solid Films, p. 64-70, 1998.	<input type="checkbox"/>

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2	Gijsbert Jan MEEUSEN, "Plasma Beam Deposition of Amorphous Hydrogenated Silicon", Thesis, University of Eindhoven, p. 16-19 (1994). <input type="checkbox"/>
3	V.J. LAW et al., "RF Probe Technology for the Next Generation of Technological Plasmas," J. Phys. D.: Appl. Phys., 34, p. 2726-2733, 2001. <input type="checkbox"/>
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